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PATENT APPLICATION

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on Nov 17, 2003.

11/17/03  
Date

Delbert J. Barnard  
Delbert J. Barnard  
Registration No. 20,515

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED  
NOV 28 2003  
TECHNOLOGY CENTER 2800

Art Unit: 2878  
Examiner: Shun K. Lee  
Applicant: Ger van den Engh  
Serial No.: 09/847,466  
Filed: May 1, 2001  
For: APPARATUS FOR DETERMINING RADIATION BEAM ALIGNMENT  
Date: November 17, 2003

RESPONSE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Office communication dated September 16, 2003, relating to the above-identified application.

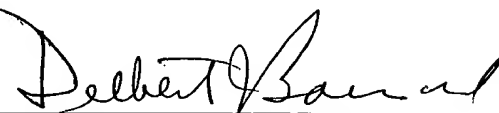
Enclosed is Exhibit A which was inadvertently omitted from the Response that was filed on June 19, 2003. It is submitted that the Response that was filed on June 19, 2003, and the

enclosed Declaration, provide a complete Response to the last Office Action.

Early reconsideration and allowance of this application are requested.

Respectfully submitted,

GER VAN DEN ENGH

By:   
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DJB/lam